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APPLICANTS

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** CONTINUING DATA *****

This application is a CON of 10/293,164 11/12/2002 PAT 6,696,224
 which is a CON of 09/614,359 07/12/2000 PAT 6,486,074

** FOREIGN APPLICATIONS *****

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
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Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged Examiner's Signature: <i>[Signature]</i> Initials: <i>[Initials]</i>	STATE OR COUNTRY ID	SHEETS DRAWING 3	TOTAL CLAIMS 16	INDEPENDENT CLAIMS 1
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TITLE

Methods of masking and etching a semiconductor substrate, and ion implant lithography methods of processing a semiconductor substrate

FILING FEE RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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